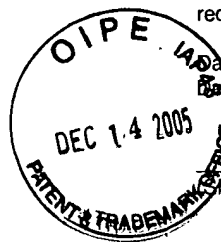


JPW

I hereby certify that this correspondence is being deposited in a first class mail envelope with the United States Postal Service addressed to : Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313. The applicant and/or attorney requests the date of deposit as the filing date.

Date of Deposit: ~~December 8, 2005~~ ^{RCF} December 12, 2005
Depositor: Robert Faber

Robert Faber ^{12-12-05 RCF}
(signature & date)



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of _____ : Date: December 8, 2005
Dureseti Chidamarrao, et al. : Group Art Unit: 2813
Serial No: 10/715,400 : Examiner: James Mitchell
Filed: 11/19/03 : International Business Machines Corporation
2070 Route 52
Hopewell Junction, NY 12533

TITLE: SILICON DEVICE ON Si:C-OI AND SGOI AND METHOD OF MANUFACTURE

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure set forth in 37 C.F.R. 1.56, and further pursuant to the provisions of 37 C.F.R. 1.97 and 1.98, applicants hereby respectfully submit copies of the US and non-US patents and publications as listed on Form PTO-1449, attached hereto.


In citing these documents, no representation is made nor intended as to the pertinency or non-pertinency of the art, that better art than that listed is not available, or that other art is not applicable.

No fee is believed to be due for this submission. If any fees are required, however, the Commissioner is hereby authorized to charge such fees to Deposit Account No. 09-0458.

Respectfully submitted,
Dureseti Chidambarao, et al.

By

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INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>						Docket Number (Optional) FIS920030242US1		Application Number 10/715,400	
				Applicant(s) Dureseti Chidambarrao, et al.				Filing Date 11/19/03	
PATENT DOCUMENTS									
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE		
		5,940,716	08/17/99	Jin, et al.					
		5,981,356	11/09/99	Hsueh, et al.					
		6,080,637	06/27/00	Huang, et al.					
		6,093,621	07/25/00	Tseng					
		6,583,060	06/24/03	Trivedi					
U.S. PATENT APPLICATION PUBLICATIONS									
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE		
FOREIGN PATENT DOCUMENTS									
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES NO		
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>									
EXAMINER					DATE CONSIDERED				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.									